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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

SEP 3 Spolicant(s): SATOH, Yoshihiro
RADEMET Serial No.: 09/981,402

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Title: Semiconductor Device and Method

for Its Manufacture

Attorney Docket No.: N320402-00W

Group Art Unit: 2815

Examiner: Richards, N. D.

AMENDMENT AFTER FINAL ACTION (37 C.F.R. §1.116)

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313

A. Introductory Comments

The following is submitted in response to the FINAL Office Action dated <u>June 2</u>, <u>2004</u>, and is currently due <u>October 4, 2004</u> with a 1-month extention.

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	37 C.F.R. §1.8
15	I hereby certify that this correspondence is being
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20	[X] deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313.
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25	Typed/Printed Name:Darryl Walker